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PPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
09/800,366	03/06/2001	Roland A. Wood	H0001512 (256.087US1)	3295
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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. P.O. BOX 2938 MINNEAPOLIS, MN 55402			LEE, SHUN K	
			ART UNIT	PAPER NUMBER
,,			2878	
			DATE MAILED: 12/31/2003	

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary		Applicati n No.	Applicant(s)				
		09/800,366	WOOD, ROLAND A.				
		Examin r	Art Unit				
		Shun Lee	2878				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SH THE - Exter after - If the - If NO - Failu - Any	ORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. Is period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period we are to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be timed within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE date of this communication, even if timely filed	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).				
1)[Responsive to communication(s) filed on <u>03 O</u>						
	,—	action is non-final.					
3)	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposit	ion of Claims						
 4) □ Claim(s) 1-27 and 29-39 is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration. 5) □ Claim(s) is/are allowed. 6) □ Claim(s) 1-27 and 29-39 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction and/or election requirement. 							
Applicat	ion Papers						
9) The specification is objected to by the Examiner.							
10)⊠ The drawing(s) filed on <u>06 March 2001</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority under 35 U.S.C. §§ 119 and 120 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
* 3 13)□ / s 3 4 14)□ /	Acknowledgment is made of a claim for loreign All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureau See the attached detailed Office action for a list Acknowledgment is made of a claim for domesticince a specific reference was included in the first 7 CFR 1.78. Acknowledgment is made of a claim for domesticince acknowledgment is made of a claim for domesticince was included in the first sentence of the ference was included in the first sentence wa	s have been received. s have been received in Application of the certified copies not received a priority under 35 U.S.C. § 119(a) st sentence of the specification of the certified copies not received a priority under 35 U.S.C. § 119(a) st sentence of the specification of the speci	ion No ed in this National Stage ed. e) (to a provisional application) r in an Application Data Sheet. ceived. and/or 121 since a specific				
Attachment(s)							
2) Notice	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449) Paper No(s) _	5) Notice of Informal F	(PTO-413) Paper No(s) Patent Application (PTO-152)				

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DETAILED ACTION

Specification

1. The amendment filed 3 October 2003 are objected to under 35 U.S.C. 132 because it introduces new matter into the disclosure. 35 U.S.C. 132 states that no amendment shall introduce new matter into the disclosure of the invention. The added material which is not supported by the original disclosure is as follows: in the paragraph beginning on page 8, line 14, "This is because the heating effect of each bias pulse is reduced by the number of bias pulses applied within the frame time." should probably be --This is because the heating effect of shorter bias pulses is less.-- (see specification as filed).

Applicant is required to cancel the new matter in the reply to this Office Action.

Claim Objections

- 2. Claims 15 and 29 are objected to because of the following informalities:
 - (a) in claim 15, "for converting the output signal to a digital signal value" on lines 3-4 should probably be --wherein said output signal produced is a digital signal value—(it should be noted that an output circuit coupled to the computing circuit to produce an output signal based on the computed average signal value for each microbolometer in the array during the frame time is recited in claim 14; see last paragraph on pg. 11); and
 - (b) in claim 29, "for converting the output signal to a digital signal value" on lines 3-4 should probably be --wherein said output signal produced is a digital signal value-- (it should be noted that an output circuit coupled to the computing circuit to

produce an output signal based on the computed average signal value for each microbolometer in the array during the frame time is recited in claim 27; see last paragraph on pg. 11).

Appropriate correction is required.

Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 4. Claims 1, 2, 7, 9-17, 20, and 22-26 are rejected under 35 U.S.C. 102(b) as being anticipated by Wood *et al.* (US 5,675,149) and incorporated by reference US Patent 5,420,419 (Wood).

It should be noted that frame time is the time in which a microbolometer produces a complete picture or image of an object being viewed (see lines 6 and 7 on pg. 2 of the specification).

In regard to claim **14**, Wood *et al.* disclose an infrared radiation detector apparatus, comprising:

- (a) microbolometers in an array (column 5, line 65 to column 6, line 1);
- (b) a timing circuit coupled to the array to apply (US 5,420,419 column 6, lines 18-34) two or more bias pulses substantially sequentially to each microbolometer in the array during a frame time (*i.e.*, the exposure time for producing a complete image; column 5, lines 47-53);

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(c) a measuring circuit coupled to the array to measure two or more resulting signals associated with each of the applied two or more bias pulses (i.e., multiple measurements; column 5, lines 47-53) during the frame time (i.e., the exposure time);

- (d) a computing circuit coupled to the measuring circuit to compute an average signal value (i.e., averaging of sensor signals; column 5, lines 47-53) for each microbolometer in the array from the measured two or more resulting signals during the frame time (i.e., the exposure time); and
- (e) an output circuit coupled to the computing circuit to produce an output signal based on the computed average value for each microbolometer in the array during the frame time (i.e., the exposure time) is inherent in displaying an image corresponding to the output signals.

In regard to claim 1, the method steps are implicit for the apparatus of Wood et al. since the structure is the same as the applicant's apparatus of claim 14.

In regard to claim 2 which is dependent on claim 1, Wood et al. also disclose (column 1, lines 55-58) recording and displaying IR images. Inherent in the formation of images is repeating the applying, measuring, computing, and producing steps to compute output signals during each frame time in order to form an IR image.

In regard to claim 7 (which is dependent on claim 1) and claim 20 (which is dependent on claim 14), Wood et al. also disclose (US 5,420,419 Fig. 6 and column 6, lines 18-34) that the bias pulses are substantially equal in magnitude.

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In regard to claim **9** (which is dependent on claim 1) and claim **22** (which is dependent on claim 14), Wood *et al.* also disclose (US 5,420,419 Fig. 6 and column 2, lines 17-20) that the two or more bias pulses comprise two or more voltage bias pulses.

In regard to claim **10** (which is dependent on claim 1) and claim **23** (which is dependent on claim 22), Wood *et al.* also disclose (US 5,420,419 column 7, lines 26-28) that the two or more resulting signals comprise two or more current signals.

In regard to claim 11 (which is dependent on claim 1) and claim 24 (which is dependent on claim 14), Wood *et al.* also disclose (column 5, lines 47-53) that multiple measurements and averaging of sensor signals is equivalent to long exposures.

Inherent in an average is at least two sensor signals each associated with an applied bias pulses and thus there are in the range of about 2 to 100 bias pulses dependent on the length of the exposure.

In regard to claim 12 (which is dependent on claim 1) and claim 25 (which is dependent on claim 24), Wood *et al.* also disclose (US 5,420,419 Fig. 6 and column 6, lines 18-34) that the two or more bias pulses have time duration in the range of about 0.1 to 20 microseconds (*e.g.*, 5-6 μ s).

In regard to claim **13** (which is dependent on claim 1) and claim **26** (which is dependent on claim 14), Wood *et al.* also disclose (column 5, lines 47-53) that multiple measurements and averaging of sensor signals is equivalent to long exposures. The exposure time (*i.e.*, frame time) is inherently the time it takes for the array to produce a complete image of an object being viewed by the array.

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In regard to claim **15** which is dependent on claim 14, Wood *et al.* also disclose (column 2, lines 57-59) that the output circuit further comprises an integrator (integrating preamplifiers 26) and an A/D converter (32) for converting the output signal to a digital signal value for each microbolometer in the array.

In regard to claim **16** which is dependent on claim 15, Wood *et al.* also disclose (column 4, lines 5-24) a digital image processor (36), coupled to the output circuit to receive the digital signal value associated with each microbolometer in the array and correct the received digital signal value for image defects.

In regard to claim **17** which is dependent on claim 16, Wood *et al.* also disclose (column 4, lines 5-24) that the digital image processor (36) further comprises a correction circuit, to apply a corrective electrical signal based on a correction value to the output signal to correct for resistance non-uniformity in each microbolometer to obtain a substantially uniform output signal value.

Claim Rejections - 35 USC § 103

- 5. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 6. Claims 3-5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Wood *et al.* (US 5,675,149) and incorporated by reference US Patent 5,420,419 (Wood) in view of Applicant Admitted Prior Art.

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In regard to claim **3** which is dependent on claim 2, the method of Wood *et al.* lacks applying a corrective electrical signal to the output signal to correct for resistance non-uniformity between the one or more microbolometers of the array to obtain a substantially uniform output signal value. Applicant admits (first paragraph on pg. 6) it is known in the art (such as US Patent 4,752,694) to apply a corrective electrical signal to the output signal to correct for resistance non-uniformity between the one or more microbolometers of the array (*i.e.*, "coarse non-uniformity correction") to obtain a substantially uniform output signal value. Therefore it would have been obvious to one having ordinary skill in the art to apply a corrective electrical signal in the method of Wood *et al.*, in order to obtain a substantially uniform output signal value.

In regard to claim 4 which is dependent on claim 3, Wood *et al.* also disclose (column 2, lines 57-59) an integrator (integrating preamplifiers 26) and an A/D converter (32) to converting the substantially uniform output signal associated with each microbolometer to a digital signal value.

In regard to claim **5** which is dependent on claim 4, Wood *et al.* also disclose (column 4, lines 5-24) passing the digital signal values associated with each microbolometer in the array through a digital image processor to correct for image defects.

7. Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Wood *et al.* (US 5,675,149) and incorporated by reference US Patent 5,420,419 (Wood) in view of Applicant Admitted Prior Art as applied to claim 5 above, and further in view of Thiede *et al.* (US 5,129,595).

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In regard to claim 6 which is dependent on claim 5, the modified method of Wood et al. lacks that the image defects comprise fine offsets, gain non-uniformity, and dead pixels. Image defects such as fine offsets, gain non-uniformity, and dead pixels are well known in the art. For example, Thiede et al. teach (column 7, lines 45-66) the correction of gain non-uniformity and dead pixels in order to fully compensate for array non-uniformity. Therefore it would have been obvious to one having ordinary skill in the art to correct for gain non-uniformity and dead pixels in the modified method of Wood et al., in order to fully compensate for array non-uniformity.

8. Claims 8, 21, 27, 29, and 33-39 are rejected under 35 U.S.C. 103(a) as being unpatentable over Wood et al. (US 5,675,149) and incorporated by reference US Patent 5,420,419 (Wood) in view of Duvall, III (US 5,258,619).

In regard to claim 8 (which is dependent on claim 1) and claim 21 (which is dependent on claim 20), the infrared radiation detector apparatus and method of Wood et al. lacks that the bias pulses are substantially equally spaced in time. Duvall, III teaches (column 6, lines 43-53) that a swept bias technique includes adjusting the waveform parameters of rise-time, fall-time, peak to peak values, time between pulses, pulse slope, pulse width, and pulse amplitude which best meets a given detector and design situation in order to minimize unwanted detector heating. Therefore it would have been obvious to one having ordinary skill in the art to adjust the bias pulses waveform parameters (e.g., pulses are substantially equally spaced in time) in the infrared radiation detector apparatus and method of Wood et al., in order to meet

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a given detector and design situation so as to minimize unwanted detector heating as taught by Duvall, III.

In regard to claim 27, Wood et al. is applied as in claim 14 above. The apparatus of Wood et al. lacks that the resulting temperature in each of the microbolometers in the array is substantially uniform. Duvall, III teaches (column 6, lines 43-53) that a swept bias technique includes adjusting the waveform parameters of rise-time, fall-time, peak to peak values, time between pulses, pulse slope, pulse width, and pulse amplitude which best meets a given detector and design situation in order to minimize unwanted detector heating. Minimizing detector heating due to bias results in minimal change in detector temperature and thus the detector is at the substantially uniform initial temperature. Therefore it would have been obvious to one having ordinary skill in the art to adjust the bias pulses waveform parameters (e.g., pulses are substantially equally spaced in time) in the infrared radiation detector apparatus and method of Wood et al., in order to meet a given detector and design situation so as to minimize unwanted detector heating resulting substantially uniform temperature as taught by Duvall, III.

In regard to claim 29 which is dependent on claim 27, Wood et al. is applied as in claim 15 above.

In regard to claim 33 which is dependent on claim 27, Wood et al. is applied as in claim 20 above.

In regard to claim 34 which is dependent on claim 27, Wood et al. in view of Duvall, III is applied as in claim 21 above.

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In regard to claims 35 and 36 which are dependent on claim 27, Wood et al. is applied as in claims 22 and 23 above.

In regard to claims 37 and 38 which are dependent on claim 27, Wood et al. is applied as in claims 24 and 25 above.

In regard to claim 39 which is dependent on claim 27, Wood et al. is applied as in claim 26 above.

9. Claims 18 and 19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Wood et al. (US 5,675,149) and incorporated by reference US Patent 5,420,419 (Wood) in view of Thiede et al. (US 5,129,595).

In regard to claim 18 which is dependent on claim 17, Thiede et al. is applied as in claim 6 above.

In regard to claim 19 which is dependent on claim 18, Wood et al. also disclose (column 4, lines 5-24) that the digital image processor (36) further comprises digital memories to store the correction values for each microbolometer in the array.

Claims 30-32 are rejected under 35 U.S.C. 103(a) as being unpatentable over 10. Wood et al. (US 5,675,149) and incorporated by reference US Patent 5,420,419 (Wood) in view of Duvall, III (US 5,258,619) as applied to claim 29 above, and further in view of Thiede et al. (US 5,129,595).

In regard to claim 30 which is dependent on claim 29, Thiede et al. is applied as in claim 6 above.

In regard to claim 31 which is dependent on claim 30, Wood et al. is applied as in claims 16 and 17 above.

In regard to claim **32** which is dependent on claim 31, Wood *et al.* is applied as in claim 19 above.

Response to Arguments

11. Applicant's arguments filed 3 October 2003 have been fully considered but they are not persuasive.

Applicant argues ("§102 Rejection of the Claims" on pg. 10-11 of remarks filed 3 October 2003) that Wood et al. do not teach applying two or more bias pulses substantially sequentially to each microbolometer in the array during a frame time. Examiner respectfully disagrees. Wood et al. states (column 5, lines 47-53) that "If desired, slower slide velocities, or multiple scans of any desired region of the scene, can be employed to allow sensitivity improvement by multiple measurement and averaging of sensor signals: in this case, a stable platform for example, a tripod mounting of the camera may be required, analogous to long exposures of visible photographic still frame cameras". The key phrase is "multiple measurement and averaging of sensor signals". Further, it is important to recognize that frame time is the time in which a microbolometer produces a complete picture or image of an object being viewed (see lines 6 and 7 on pg. 2 of the specification as filed). Thus, Wood et al. disclose obtaining sensor signal averages of the multiple measurements (wherein each measurement corresponds to a second short duration bias pulse and the timing between substantially sequentially short duration bias pulses is adjusted such that "each said unit has time to return to a stabilization temperature") so as to produce a complete picture or image within the exposure time (i.e., frame time). Therefore, Wood et al.

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teaches applying two or more bias pulses substantially sequentially to each microbolometers in the array during a frame time in order to obtain long exposure IR images.

In response to applicant's arguments ("§103 Rejection of the Claims" on pg. 11-12 of remarks filed 3 October 2003) against the references individually, one cannot show nonobviousness by attacking references individually where the rejections are based on combinations of references. See In re Keller, 642 F.2d 413, 208 USPQ 871 (CCPA 1981); In re Merck & Co., 800 F.2d 1091, 231 USPQ 375 (Fed. Cir. 1986).

Conclusion

THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time 12. policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

13. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shun Lee whose telephone number is (703) 308-4860. The examiner can normally be reached on Monday-Thursday.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Porta can be reached on (703) 308-4852. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

SL

SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800